



42P16442

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
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Venkateshwaran et al.) Examiner: Hughes, Deandra M.
)
Serial No. 10/606,637) Art Unit: 3663
)
Filed: June 25, 2003)
)
For: THERMAL TUNING OF A LASER USING)
DOPED SILICON ETALON)
)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE AND AMENDMENT UNDER 37 C.F.R. §§1.111 AND 1.121

Sir or Madam:

In response to the Office Action mailed June 8, 2005, Applicants submit the following Amendment and Remarks. Claim Amendments begin on page 2 of this paper. Remarks begin on page 5 of this paper. Applicants respectfully request that the Examiner reconsider the application.

It is not believed that extensions of time are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a). Any fees required therefore are hereby authorized to be charged to Deposit Account No. 02-2666. Please credit any overpayment to the same deposit account.

Kindly enter the following Amendment and consider the following Remarks.